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Attorney Docket No. 2267.416US02

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MAR 11 2003  
TECHNOLOGY CENTER R3700

AMENDMENT TRANSMITTAL

In re the application of:

NYSETH

Confirmation No.: 7509

Application No.: 09/523,745

Examiner: David Fidei

Filed: March 13, 2000

Group Art Unit: 3728

For: WAFER CONTAINER WITH MINIMAL CONTACT

Commissioner for Patents  
Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment, Terminal Disclaimer, Certificate Under 37 C.F.R. § 3.73(b) and Petition for Extension of Time in the above-identified application.

☐ Applicant(s) is/are entitled to small entity status in accordance with 37 CFR 1.27.

The filing fee has been calculated as shown below:

	Claims Remaining After Amendment	Highest No. Previously Paid For	Present Extra (Equals)	Small Entity Rate	Add'l Fee	OR	Large Entity Rate	Add'l Fee
Total	17	- [20]**	= 0	x 9	\$		x 18	\$0
Indep.	4	- [3]***	= 1	x 42	\$		x 84	\$84
Mult. Dep.			=	+ 140	\$		+ 280	\$
TOTAL					\$	OR	TOTAL	\$84.00

☐ First Presentation of Multiple Dependent Claim [MDC]

- \* If the entry in Column 1 is less than the entry in Column 2, write "0" in Column 3.  
\*\* If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.  
\*\*\* If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.  
The "Highest Number Previously Paid For" (Total or Independent) is the highest number found from the equivalent box in Column 1 of a prior Amendment or the number of claims originally filed.

*[Handwritten signature]*

Application No. 09/523,745

- [ X ] The Commissioner is authorized to charge Deposit Account No. 16-0631 in the amount of \$1,124.00 for the additional claims fee, Petition for Extension of Time and Terminal Disclaimer filing fee.

Respectfully submitted,



Douglas J. Christensen  
Registration No. 35,480

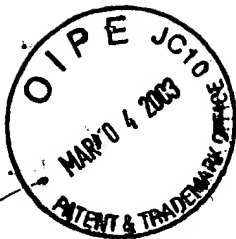
*Please grant any extension of time necessary for entry; charge any fee due to Deposit Account No. 16-0631.*

CERTIFICATE OF MAILING

I hereby certify that this document is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on

2-27-03  
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\_\_\_\_\_  
Douglas J. Christensen



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Attorney Docket No.: 2267.416US02

NYSETH

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AMENDMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

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TECHNOLOGY CENTER R3700

Sir:

In response to the Office Action of August 27, 2002, and in accordance with the automatic extension of time for response provided by 37 C.F.R. § 1.136(a), amendment to the above-identified patent application is requested.

In the Claims

Please substitute the following amended claims for those currently pending:

6. (Once Amended) A wafer carrier for holding wafers in a substantially horizontal arrangement, the wafers having a lower surface, the carrier having an open front, a backside, a top portion, a bottom portion, a left side and a right side, the carrier further comprising:

a pair of wafer support columns extending from the top portion to the bottom portion, one support column located at the right side and one located at the left side, each wafer support column comprised of a plurality of vertically arranged elongate shelves, each shelf comprised of at least two upwardly extending elongate beads oriented inwardly with respect to the wafers and transversely with respect to the plurality of vertically arranged shelves for providing minimal contact with the lower surface of a wafer at each bead, each shelf further having an insertion level and a seating level for a wafer, whereby a wafer may be inserted into the carrier through the

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